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OCT 25 2005

PATENT  
90065.99R272 (17732.6323)  
Response Under 37 CFR 1.111

## IN THE UNITED STATES PATENT &amp; TRADEMARK OFFICE

Applicant: Jifa Hao, et al.

Serial No.: 09/654,845

Filed: September 01, 2000

Title: POWER SEMICONDUCTOR  
DEVICE WITH HIGH  
AVALANCHE CAPABILITY AND  
PROCESS FOR FORMING  
SAME

Examiner: Ori Nadav

Art Unit: 2811

## RESPONSE UNDER 37 CFR 1.116

MS: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed October 11, 2005, Applicants hereby submit the following Amendment and Remarks.

*Intermed  
copy  
1-12-06  
Dennis  
1-18-06*

ROCHDOCS03956591

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